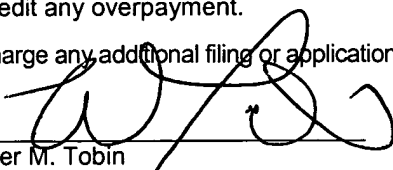




AF
JRW

| AMENDMENT TRANSMITTAL LETTER | | | | Docket No. SON-2612/DIV | |
|--|---|---|-----------------------------------|--------------------------------|------|
| Application No. 10/785,005-Conf. #9742 | | Filing Date February 25, 2004 | | Examiner T. X. Le | |
| | | | | Art Unit 2814 | |
| Applicant(s): Shigeru Fujita | | | | | |
| Invention: SEMICONDUCTOR DEVICE AND ITS MANUFACTURING METHOD | | | | | |
| TO THE COMMISSIONER FOR PATENTS | | | | | |
| Transmitted herewith is an amendment in the above-identified application. | | | | | |
| The fee has been calculated and is transmitted as shown below. | | | | | |
| CLAIMS AS AMENDED | | | | | |
| | Claims Remaining After Amendment | Highest Number Previously Paid | Number Extra Claims Present | Rate | |
| Total Claims | 9 | - 20 = | | x | |
| Independent Claims | 2 | - 3 = | | x | |
| Multiple Dependent Claims (check if applicable) <input type="checkbox"/> | | | | | |
| Other fee (please specify): | | | | | |
| TOTAL ADDITIONAL FEE FOR THIS AMENDMENT: | | | | | 0.00 |
| <input checked="" type="checkbox"/> Large Entity <input type="checkbox"/> Small Entity | | | | | |
| <input checked="" type="checkbox"/> No additional fee is required for this amendment. | | | | | |
| <input type="checkbox"/> Please charge Deposit Account No. _____ in the amount of \$ _____. A duplicate copy of this sheet is enclosed. | | | | | |
| <input type="checkbox"/> A check in the amount of \$ _____ to cover the filing fee is enclosed. | | | | | |
| <input type="checkbox"/> Payment by credit card. Form PTO-2038 is attached. | | | | | |
| <input checked="" type="checkbox"/> The Director is hereby authorized to charge and credit Deposit Account No. <u>18-0013</u> as described below. A duplicate copy of this sheet is enclosed. | | | | | |
| <input checked="" type="checkbox"/> Credit any overpayment. | | | | | |
| <input checked="" type="checkbox"/> Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17. | | | | | |
|  Christopher M. Tobin Attorney Reg. No.: 40,290 | | | | Dated: <u>January 19, 2006</u> | |
| RADER, FISHMAN & GRAUER PLLC 1233 20th Street, N.W. Suite 501 Washington, DC 20036 (202) 955-3750 | | | | | |



Docket No.: SON-2612/DIV
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Shigeru Fujita

Application No.: 10/785,005

Confirmation No.: 9742

Filed: February 25, 2004

Art Unit: 2814

For: SEMICONDUCTOR DEVICE AND ITS
MANUFACTURING METHOD

Examiner: LE, Thao X

AMENDMENT AFTER FINAL ACTION (37 C.F.R. SECTION 1.116)

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated December 12, 2005, please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.